

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Applicants: Andreas Wittmann et al.

Serial No: 09/993,824

Filed:

November 6, 2001

Title:

ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS

Art Unit:

2828

Examiner: Dung T. Nguyen

POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST (REVOCATION OF PRIOR POWERS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The assignee of the entire right, title and interest of the above identified patent application, hereby revokes all powers of attorney previously given and hereby appoints the following attorneys to prosecute and transact all business in the Patent and Trademark Office connected with the above referenced application.

Mark D. Saralino, Registration No. 34,243

Send correspondence and direct telephone calls to:

Mark D. Saralino, Esq. RENNER, OTTO, BOISSELLE & SKLAR 1621 Euclid Avenue, 19th Floor Cleveland, Ohio 44115

> Tel: 216-621-1113 Fax: 216-621-6165

The undersigned has reviewed all the documents in the chain of title of the patent application identified above and, to the best of the undersigned's knowledge and belief, title is in the assignee identified below.

A statement under 37 CFR 3.73(b) is submitted herewith.

The undersigned further declares that he is empowered to act on behalf of the assignee, and that all statements made herein of his own knowledge are true, and that all statements made on information and belief are believed to be true; and further, that these statements are made with the knowledge that willful false statements, and the like so made, are punishable by fine or imprisonment, or both, under Section 1001, Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

BOOKHAM TECHNOLOGY PLC

Intellectual Property Manager

Z:\SEC154\MDS\ABAC\P106us\POA Revocation.wpd;POW-ASS.FRM (9/96)



PTO/SB/96 (08-00) Approved for use through 10/31/2002, OMB 0651-0031 U.S.Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Docket No.ABACP0106US

STATEMENT UNDER 37 CFR 3.73(b) Applicant/Patent Owner: Andreas Wittmann, et al. Filed/Issue Date: November 6, 2001 Application No./Patent No.: 09/993,824 Entitled: ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS BOOKHAM TECHNOLOGY PLC Corporation (Name of Assignee) (Type of Assignee, e.g., corporation, partnership, university, government agency, etc.) states that it is: 1. The assignee of the entire right, title, and interest; or 2. \square an assignee of less than the entire right, title and interest. The extent (by, percentage) of its ownership interest is in the patent application/patent identified above by virtue of either: A. [] An assignment from the inventor(s) of the patent application/patent identified above. The assignment was recorded in the United States Patent and Trademark Office at Reel _____, Frame which a copy thereof is attached. OR B. [A A chain of title from the inventor(s), of the patent application/patent identified above, to the current assignee as shown below: To: Nortel Networks Corp. 1. From: Andreas Wittmann, et al. The document was recorded in the United States Patent and Trademark Office at Reel 012329 ____, Frame_0214 , or for which a copy thereof is attached. To: BOOKHAM TECHNOLOGY PLC 2. From: Nortel Networks Corp. The document was recorded in the United States Patent and Trademark Office at __, or for which a copy thereof is attached. 3. From: To: The document was recorded in the United States Patent and Trademark Office at ____, Frame_ __, or for which a copy thereof is attached. [] Additional documents in the chain of title are listed on a supplemental sheet. [X] Copies of assignments or other documents in the chain of title are attached. [NOTE: A separate copy (i.e., the original assignment document or a true copy of the original document) must be submitted to Assignment Division in accordance with 37 CFR Part 3, if the assignment is to be recorded in the records of the USPTO. See MPEP 302.08] The undersigned (whose title is supplied below) is authorized to act on behalf of the assignee.

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Assistant Commissioner for Patents, Washington, DC 20231.

Intellectual Property Manager

Title

AMENDMENT TO THE PATENT ASSIGNMENT AGREEMENT

This Amendment (this "Amendment"), effective as of November 8, 2002, to the Patent Assignment Agreement made on November 8, 2002 (the "PAA") is hereby made by and among NORTEL NETWORKS CORPORATION, a corporation duly incorporated under the laws of Canada, having its executive offices at 8200 Dixie Road, Suite 100, Brampton, Ontario L6T 5P6 Canada, and each of its subsidiaries that are listed on the signature pages hereto (collectively, the "Assigning Parties") and BOOKHAM TECHNOLOGY PLC, a public limited company incorporated under the laws of England and Wales having its executive offices at 90 Milton Park, Abingdon, Oxfordshire OX14, 4RY United Kingdom (the "Assignee") (each of the Assigning Parties and Assignee, a "Party" and, collectively, the "Parties").

WHEREAS, the Parties, having entered into the PAA, desire to amend the PAA to update the schedule of patents, patent applications and invention disclosures attached thereto.

NOW THEREFORE, in consideration of the foregoing premises and the mutual terms and conditions set forth herein, and for U.S. \$1.00 (ONE DOLLAR) and other good and valuable consideration, receipt and adequacy of which is hereby acknowledged, the Parties hereby agree that the PAA be, and is, amended as follows:

- 1. <u>Schedule A</u> of the PAA is deleted in its entirety and replaced with the new <u>Schedule A</u> attached hereto.
- 2. Except as expressly amended by this Amendment, all of the terms, covenants and conditions of the PAA shall remain unamended and in full force and effect.
- 3. This Amendment is hereby incorporated in, and forms a part of, the PAA. For the avoidance of doubt, this Amendment shall be governed by and enforced in accordance with the laws of the State of New York, without giving effect to any conflicts of law principles.
- 4. This Amendment shall be binding on, and shall inure to the benefit of, the Parties and their respective successors and assigns.
- 5. This Amendment may be executed in any number of counterparts, each of which shall be deemed to be an original but all of which shall constitute one and the same instrument.

[Remainder of page intentionally left blank]

IN WITNESS WHEREOF, the Parties have duly executed this Amendment as of the date first above written.

Fact

NORTEL NETWORKS
CORPORATION

By:
Name: Khush Dadyburjor, as Attorney-inFact

NORTEL NETWORKS
INCORPORATED

By:
Name: Khush Dadyburjor, as Attorney-inFact

NORTEL NETWORKS LIMITED

By:
Name: Khush Dadyburjor, as Attorney-inFact

NORTEL NETWORKS PROPERTIES
LIMITED

By:
Name: Khush Dadyburjor, as Attorney-in-

NORTEL NETWORKS
TECHNOLOGY CORPORATION
1111 July
Ву:
Name: Khush Dadyburjor, as Attorney-in-
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NORTEL NETWORKS (ASIA)
LIMITED
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By:
Name: Khush Dadyburjor, as Attorney-in-
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NORTEL NETWORKS OPTICAL
COMPONENTS (SWITZERLAND)
GmbH SWITZERLAND)
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Name: Khush Dadyburjor, as Attorney-in-
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NORTEL NETWORKS (U.K.)
LIMITED
By:
Name: Khush Dadyburjor, as Attorney-in-
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By:
Name: Khush Dadyburjor, as Attorney-in-
Fact

NORTEL NETWORKS OPTICAL COMPONENTS INCORPORATED
By: Malt skyly
Name: Khush Dadyburjor, as Attorney-in Fact
NORTEL NETWORKS HPOCS INCORPORATED By: Name: Khush Dadyburjor, as Attorney-in Fact
NORTEL NETWORKS PHOTONICS PTY LIMITED By: Name: Khush Dadyburjor, as Attorney-in- Fact
NORTEL NETWORKS SHANNON LIMITED By:
Name: Khush Dadyburior as Attorney-in-

Fact

	BOOKHAM	TECHNOL	OGY	PLC
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By:___ Name: Title:

On this on day of Beeember, 2002, before me appeared that he/she signed it as a free act on his/her own

On this day of December, 2002, before me appeared who signed this instrument, who acknowledged that he/she signed it as a free act on his/her own behalf or on behalf of Bookham Technology plc with authority to do so.
State of hard) County of Ck Justines) ss.
County of Charles SS.
Hend Cemb.

STUART P. B. CAPEL SOLICITOR & NOTARY PUBLIC 6 EAST SAINT HELEN STREET ABINGDON, OXON, OX14 5EW TEL: 01235 - 523411 FAX: 01235 - 533283

SCHEDULE A

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10289F	RO PHOTODETECTOR WIT SPECTRALLY EXTENDE RESPONSIVITY		2,269,298				PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY
10289F	RO PHOTODETECTOR WIT SPECTRALLY EXTENDE RESPONSIVITY		09/294,114	6,222,200			PHOTODETECTOR WITH SPECTRALLY EXTENDED RESPONSIVITY
10412R	LASER	US	09/688,873				EXTERNAL CAVITY LASER USING ANGLE-TUNED FILTER AND METHOD OF MAKING SAME
104131	COMPOUND GRADED INDEX LENSES						FIBRE TERMINATION COMPOUND GRADED INDEX LENSES
10485R	O ELECTRICALLY CONTROLLED OPTICAL ATTENUATOR WITH COPLANAR ELECTRODE	1	09/726,409				ELECTROCHROMIC OPTICAL ATTENUATOR
10509R	FOR SEMICONDUCTOR OPTICAL DEVICES UPOI CARRIERS		09/472,121	6,287,401			ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS
10509R	O ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPOI CARRIERS		2,328,279				ALIGNMENT METHOD FOR SEMICONDUCTOR OPTICAL DEVICES UPON CARRIERS
1100610	ASSEMBLIES	US	09/496,917				MODULATOR ASSEMBLIES
1192010	AMPLIFICATION DEVICE		09/557,891				PUMPED OPTICAL AMPLIFICATION DEVICE
11945ID		US	09/573,238				A RAMAN FIBRE LASER
11954ID		US	09/573,236				A RAMAN FIBRE LASER
12242RC	AVALANCHE PHOTODIODE	US	09/733,060				EPITAXIALLY GROWN AVALANCHE PHOTODIODE
12339ID	OPTICAL FIBER DEVICE	US	09/653,985				OPTICAL FIBER DEVICE
12349RC	COMPACT CHIP LABELING USING STEPPER TECHNOLOGY.	CA	2,320,612				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12349RC	LABELING USING STEPPER TECHNOLOGY.	US	09/688,366				COMPACT CHIP LABELING USING STEPPER TECHNOLOGY
12526RO	SELF ADJUSTING APPARATUS FOR GRIPPING AND MICRO- MANIPULATING CERAMIC SUBSTRATES	US	09/660,542	6,409,241			APPARATUS FOR GRIPPING CERAMIC SUBSTRATES
12615ID	PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE	US	09/676,256				PACKAGING ATMOSPHERE AND METHOD OF PACKAGING A MEMS DEVICE
12634RO	BE DOPING OF INP	US	09/741,350				STRUCTURE AND METHOD FOR DOPING OF III-V COMPOUNDS
12665RO	PRINT QUALITY TEST STRUCTURE FOR DEVICE MANUFACTURING.	US	09/667,620				PRINT QUALITY TEST STRUCTURE FOR LITHOGRAPHIC DEVICE MANUFACTURING
12686ID	GLASS FIBER FIXATIVE AND FIXING PROCESS	US	09/698,800				GLASS FIBER FIXATIVE AND FIXING PROCESS
12715RO	METHOD OF MAKING GRATINGS ON TUNABLE LASER DEVICES	US	09/667,622				METHODS FOR MAKING PATTERNS IN RADIATION SENSITIVE POLYMERS

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12800	FILTER			5,930,44	1		SPLIT-BEAM FOURIER FILTER
128411	TRANSMITTER	- U:	09/616,659				INTEGRATED OPTICAL TRANSMITTER
12847F	BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER	. C	2,328,641				CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
12847R	O BURIED HETEROSTRUCTURE LASER CONFINEMENT LAYER	US	10/014,807				CONFINEMENT LAYER OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
1284910	OPTICAL AMPLIFIER METHOD AND APPARATUS	US	09/710,372				OPTICAL AMPLIFIER METHOD AND APPARATUS
1284910	METHOD AND APPARATUS	wc	PCT/GB01/04944	1			OPTICAL AMPLIFIER METHOD AND APPARATUS
129481	O OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	US	09/731,434				OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
1294810	OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE	CA	2,364,383				OPTICAL AMPLIFIER, OPTICAL AMPLIFIER HYBRID ASSEMBLY AND METHOD OF MANUFACTURE
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		08/726,049	6,041,071			ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		60/004,620				AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH
	AGILE, WIDELY TUNABLE DIODE LASER WITH NARROW LINEWIDTH		09/532,529				ELECTRO-OPTICALLY TUNABLE EXTERNAL CAVITY MIRROR FOR A NARROW LINEWIDTH SEMICONDUCTOR LASER
13144CK	LASER WITH SETTABLE WAVELENGTHS	US			Mailed Application	TAYEBATI, PARVIZ (7043-5010439), VAKHSHOORI, DARYOOSH (7068- 5010442)	LASER WITH SETTABLE WAVELENGTHS
13144CK	WAVELENGTHS	US	60/099,252				LASER WITH SETTABLE WAVELENGTHS
13144CK	WAVELENGTHS	US	60/099,308				LASER WITH SETTABLE WAVELENGTHS
1	LASER WITH SETTABLE WAVELENGTHS		09/386,604				LASER WITH SETTABLE WAVELENGTHS
13144CK	LASER WITH SETTABLE WAVELENGTHS	CA	2,317,133				LASER WITH SETTABLE WAVELENGTHS
	SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	us	60/148,017				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	WAVELENGTH REFERENCE DEVICE	US	09/636,817				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE				Nat'l Phase Filed		SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
	WAVELENGTH REFERENCE DEVICE	CA	2,381,662				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13199CK	SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	EP	973357.7				SINGLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE

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13201C		US			Status	e Deput (los	
1320101	OPTICAL WAVELENGTH REFERENCE DEVICE		60/148,148				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201C	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE		PCT/US00/2190	5	Nat'l Phase Filed	е	DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201C	ODUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE	US	09/636,807				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201C	OPTICAL WAVELENGTH REFERENCE DEVICE	CA	2,381,665				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13201Ck	OPTICAL WAVELENGTH REFERENCE DEVICE		00957375.9				DOUBLE ETALON OPTICAL WAVELENGTH REFERENCE DEVICE
13391RC	INTEGRATED OPTICALLY PUMPED EDGE EMITTING SEMICONDUCTOR LASER	3	09/987,785				MONOLITHICALLY INTEGRATED OPTICALLY-PUMPED EDGE- EMITTING SEMICONDUCTOR LASER
13417RC	GRATING ETCHING WITH INP MASKING	US	09/750,124				METHOD OF ETCHING PATTERNS INTO EPITAXIAL MATERIAL
13444CK	MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS	US	09/859,938				MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS
13444CK	MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS	wo	PCT/US01/14918				MICROELATION FOR DWDM TELECOMMUNICATIONS APPLICATIONS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	US	09/821,580				METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	EP	02251194.3	·			METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13494ID	METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN	CA	2,374,557		,		METHOD AND APPARATUS FOR MINIMIZING GAIN DEVIATION IN OPTICAL FIBRE AMPLIFIERS
13495ID	OPTICAL MODULATORS	US	09/679,165	6,377,717			OPTICAL MODULATORS
13502RO	ANGLED OUTPUT BALL TAPERED OPTICAL FIBER TERMINATION	US	09/735,571				OPTICAL FIBER TERMINATION
13524RO	A STATISTICAL MODEL USED TO CONTROL THE LASING WAVELENGTH OF SEMICONDUCTOR LASERS	US	10/196,956				A METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR LASERS
13544RO	SEMICONDUCTOR LASERS	US	10/141,914				SEMICONDUCTOR LASER
13584RO	ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING	US	09/709,646				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13584RO	ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING	CA	2,361,683				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13584RO	ELECTRODE METAL TERMINATION FOR REDUCED LOCAL HEATING	EP	01309541.9				ELECTRODE TERMINATION FOR REDUCED LOCAL HEATING IN AN OPTICAL DEVICE
13591ID	OPTICAL MODULATORS	GB	0031241.3				OPTICAL MODULATORS

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13591ID	OPTICAL MODULATORS	WC					OPTICAL MODULATOR
13614ID	OPTICAL PULSE GENERATION	US	09/993,849				OPTICAL PULSE GENERATION
13614ID	OPTICAL PULSE GENERATION	wc	PCT/GB02/0366	4			OPTICAL PULSE GENERATION
13721RC	AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AND UNIFORMITY CROSS A WAFER	US	0		Mailed Application	QIAN, YAHONG (C115-0531819,1), AN SERGUEI (5C33- 0510038,1)	AN NON-DESTRUCTIVE AND FAST WAY TO DETECT DIFFUSION DEPTH AD UNIFORMITY CROSS A WAFER
13813RC	HIGH POWER LASER DIODE AND METHOD OF FABRICATION THEREOF		10/141,862				MONOLITHICALLY INTEGRATED HIGH POWER LASER OPTICAL DEVICE
13816RC	APPARATUS FOR MONITORING THE OUTPUT POWER OF DIODE LASERS AND MODULATORS				Unfiled		
14224ID	ISOLATION OF MICROWAVE TRANSMISSION LINES	US	10/032,416				ISOLATION OF MICROWAVE TRANSMISSION LINES
14404RO	HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER	US	10/027,229	·			HYBRID CONFINEMENT LAYERS OF BURIED HETEROSTRUCTURE SEMICONDUCTOR LASER
14429ID	OPTICAL BEAM SAMPLING MONITOR	US	10/006,509				OPTICAL BEAM SAMPLING MONITOR
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	CA	2,292,769				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	EP	99919257.8				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	JP	11-552490				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	US	09/063,173	6,204,560			TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD		10-1999-7012042				A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD
14433JD	TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON-SILICON TECHNOLOGIES AND METHOD	wo	PCT/EP99/02665		Nat'l Phase Filed		A TITANIUM NITRIDE DIFFUSION BARRIER FOR USE IN NON- SILICON TECHNOLOGIES AND METALLIZATION METHOD

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14433J	D TITANIUM NITRIDE DIFFUSION BARRIER FO USE IN NON-SILICON TECHNOLOGIES AND METHOD	JP R	0			DAETWYLER, ANDREAS (- GPS4097856), DEUTSCH, URS (EXTR-GPS4097859) HARDER, CHRISTOPI (AA54-5050202), HEUBERGER, WILHELM (EXTR-GPS4097866), LATTA ERNST-EBERHARD (EXTR-GPS4097878), JAKUBOWICZ, ABRAN (-GPS4097872), OOSENBRUG, ALBERTUS (- GPS4097875)	
14434J[SOURCE	EP	99810837.7				STABILIZED LASER SOURCE
14434J[STABILIZED LASER SOURCE	US	10/049,886				STABILIZED LASER SOURCE
14435J[SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT		99811030.8				SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14435JC	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	1	PCT/IB00/01530		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR OPTICAL FIBER FIXING AND SUBMICRONFINE ALIGNMENT
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	US	PCT/IB00/01530		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14435JD	SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT	CA	2,390,916		Nat'l Phase Filed		SUPPORTING STRUCTURE FOR FIBER FIXING AND SUBMICRON FINE ALIGNMENT
14480RC	GAIN COUPLED DISTRIBUTED FEEDBACK LASER USING SELF- ASSEMBLED QUANTUM DOTS				Unfiled		
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	US	09/852,994				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	SEMICONDUCTOR LASER DIODE		2,385,653				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE		2405380.3				HIGH POWER SEMICONDUCTOR LASER DIODE
14549JD	HIGH POWER SEMICONDUCTOR LASER DIODE	JP	2002-134066				HIGH POWER SEMICONDUCTOR LASER DIODE
14551JD	CARRIER DESIGN FOR MODULES WITH HIGH POWER LASER DIODES	US	10/026,150				HIGH POWER LASER CARRIER
14552JD	ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS	US	09/998[824				ANTI-REFLECTION COATINGS FOR SEMICONDUCTOR LASERS
14592ID	OPTICAL COMPONENT ALIGNMENT TECHNIQUE	US	10/024,972				GIMBALLED LENS MOUNT AND ALIGNMENT ASSEMBLY FOR A SENSITIVE OPTICAL ALIGNMENT
14676RO	ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS	US	60/334,013			15	ENHANCED LINK OPERATION OF DIRECTLY MODULATED LASERS USING GAIN-COUPLED GRATINGS

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14676RC	OPERATION OF DIRECTLY MODULATED LASERS USING GAIN- COUPLED GRATINGS		10/025,866		z Status	A Maria Dept.	ENHAN DIRECT	CED LINK OPERATION OF TLY MODULATED LASERS .ED-COUPLED GRATINGS
14681ID	THERMAL COMPENSATION AND ALIGNMENT FOR OPTICAL DEVICES	US	10/032,421				THERM	IAL COMPENSATION AND BNMENT FOR OPTICAL DEVICES
14716RC	WAVEGUIDE MODE STRIPPER FOR INTEGRATED OPTICAL COMPONENTS	US	10/073,101				WAVE FOR	GUIDE MODE STRIPPER INTEGRATED OPTICAL COMPONENTS
14794RO	A METHOD FOR MAKING FLOATING GRATINGS	US	10/259,745				FLOA	D AND APPARATUS FOR TING GRATINGS IN DFB TRIBUTED FEEDBACK) LASERS
14854RO	A METHOD FOR MINIMIZING CROSSTALK DUE TO LASER WAVELENGTH VARIATIONS WITH NON- IDEAL FILTERS				Unfiled			
14864RO	POLARIZATION AND WAVELENGTH INDEPENDENT MHZ SPEED OPTICAL ATTENUATOR	US	10/190,592					RENT TUNED MACH- EHNDER OPTICAL ATTENUATOR
14942RO	RE-CIRCULATING OPTICAL PULSE GENERATOR	US	10/116,168					IRCULATING OPTICAL JLSE GENERATOR
15004RO	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)		10/098,446				VARIABI OPT	CRO-MIRRORS WITH LE FOCAL LENGTH, AND TICAL COMPONENTS TISSING MICRO-MIRRORS
15004RO	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)		10/098,446				VARIABI OPT	RO-MIRRORS WITH LE FOCAL LENGTH, AND FICAL COMPO ENTS ISING MICRO-MIRRORS
15004RO	DEFORMABLE POLYMER MICRO MIRRORS (DPMM)		10/098,446				VARIABI OPT	RO-MIRRORS WITH LE FOCAL LENGTH, AND ICAL COMPONENTS ISING MICRO-MIRRORS
15093RO	MULTIPLE-CONTACT SEMICONDUCTOR OPTICAL AMPLIFIERS	ÜS	60/414,404				MULTIP	LE-CONTACT OPTICAL AMPLIFIERS
15095RO	FREQUENCY IDENTIFICATION WITH A FREQUENCY LOCKER	US	10/108,856	,				ENCY IDENTIFICATION FREQUENCY LOCKER
15113CK	METHOD TO IMPROVE TEMPERATURE STABILITY OF FREQUENCY LOCKER IN OPTOELECTRONIC MODULES	US	10/165,465					LENGTH STABILIZED OPTICAL DEVICE
15116JD	NEW STRAIGHT-FLARED- STRAIGHT WAVEGUIDE DESIGN	US	10/131,335				LASER DI	WER SEMICONDUCTOR IODE AND METHOD FOR ING SUCH A DIODE
15117JD	PUMP LASER DIODE WITH IMPROVED WAVELENGTH STABILITY	US	0					LASER DIODE WITH DVED WAVELENGTH STABILITY
15138ID	AN IMPROVED METHOD FOR TERMINATING AN OPTICAL WAVEGUIDE INTO AN OPTICAL COMPONENT	US	10/161,523				TERMI	ROVED METHOD FOR NATING AN OPTICAL JIDE INTO AN OPTICAL COMPONENT

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15142RC	INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES	US	60/352,572		a status	Dept No Sa	FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS
15142RC	SINGLE MODE, HIGH INDEX CONTRAST POLYMER FLEXIBLE WAVEGUIDES	US	60/352,572				FLEXIBLE POLYMER WAVEGUIDES FOR OPTICAL WIRE BONDS
15150RC	METHOD FOR INTEGRATING A LASER WITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP	US	0		Mailed Application	GLEW, RICK (C116- 2819324), BETTY, IAN (5C33-0519725), GREENSPAN, JONATHAN (C116- 0262541)	
15150RO	METHOD FOR INTEGRATING A LASER WITH A WAVEGUIDE IN A SINGLE EPITAXIAL GROWTH STEP	US	0		Mailed Application	GLEW, RICK (C116- 2819324), BETTY, IAN (5C33-0519725), GREENSPAN, JONATHAN (C116- 0262541)	EPITAXIAGROWTH STEP
15164RO	A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	. 0		Mailed Application	GLEW, RICK (C116- 2819324), REID, BENOIT (5C32- 0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568)	A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15164RO	A DOPANT-INDUCED REAL REFRACTIVE INDEX-GUIDED SELF- ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER.	US	0		Mailed Application	GLEW, RICK (C116- 2819324), REID, BENOIT (5C32- 0531388), LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568)	A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15181ID	LASER TRANSMITTER	υs	60/391,648			000000)	LASER TRANSMITTER
15181ID	LASER TRANSMITTER	US	60/391,648				LASER TRANSMITTER
15193RO	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER	US	60/380,261				OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIATION CONVERTER
15193RO	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIZATION CONVERTER	US			Mailed Application	EL-REFAEI, HATEM (5C33-0273812), JONES, TREVOR (C115-1342592,2), YEVICK, D (EXTR- GPS0380642,2)	OPTIMIZED PERFORMANCE OF INGAASP/INP COMPACT ON-CHIP POLARIATION CONVERTER
15320RO	ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP	US	0		Mailed Application	PROSYK, KELVIN (5C33-0526051), BETTY, IAN (5C33- 0519725)	ELECTRO-OPTIC MODULATOR WITH CONTINUOUSLY ADJUSTABLE CHIRP
15338RO	HIGH POWER DISTRIBUTED FEEDBACK LASER				Unfiled		
15386JD	RIDGE WAVEGUIDE LASER DIODE WITH COMPLEX INDEX GUIDING LAYER	US	0		Mailed Application		HIGH POWER SEMICONDUCTOR LASER DIODE AND METHOD FOR MAKING SUCH A DIODE
15389JD	LASER STABILIZATION USING VERY HIGH RELATIVE FEEDBACK				Unfiled		

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15390R	O ON-CHIP POLARIZATION	V US	60/404,166		# Status	Deni Ngg	
153500	SPLITTER/COMBINER DEVICE						ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
15390R	O ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE	1 US	60/404,166				ON-CHIP POLARIZATION SPLITTER/COMBINER DEVICE
	D A GUIDED SELF-ALIGNEI LASER STRUCTURE WIT INTEGRAL CURRENT BLOCKING LAYER	Н	60/390,882				A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15399J[D A GUIDED SELF-ALIGNEI LASER STRUCTURE WITI INTEGRAL CURRENT BLOCKING LAYER				Mailed Application	LICHTENSTEIN, NORBERT L (AA55- 5050260), FILY, ARNAUD (AA55- 5053568,1), SCHMIDT, BERTHOLD (AA54- 5050359,2), REID, BENOIT (5C32- 0531388,2), KNIGHT, D. GORDON (C116- 1529664,1)	A GUIDED SELF-ALIGNED LASER STRUCTURE WITH INTEGRAL CURRENT BLOCKING LAYER
15502R0	A P-SUBSTRATE SELF- ALIGNED LASER STRUCTURE WITH IRON DOPED CURRENT BLOCKING LAYERS				Unfiled	.02000 ,,,,	
15507RC	A MAGNETO-OPTIC NONRECIPROCAL WAVEGUIDE TE/TM MODE CONVERTER IN SEMICONDUCTING MATERIALS				Unfiled		
15558RC	MANUFACTURE OF A GRATING TEMPLATE AND ITS TRANSFER INTO AL (IN, GA)AS MATERIAL USING IN-SITU ETCHING AND REGROWTH INSIDE A GROWTH REACTOR.				Unfiled		
15592RO	ETCHING OF INDEX- OR GAIN-COUPLED GRATINGS INTO INGAASP MATERIAL USING IN-SITU ETCHING IN A GROWTH REACTOR				Unfiled		
	LASER STRUCTURE WITH LARGE OPTICAL SUPERLATTICE WAVEGUIDE				Unfiled		
15655RO	HIGH TEMPERATURE OPERATION LASER DIODES				Unfiled		,
15656RO	FABRICATION OF A BURIED HETEROSTRUCTURE LASER WITH AN INGAASP ACTIVE LAYER USING IN- SITU ETCHING IN A GROWTH REACTOR		,		unfiled		
HQ0054	SUPERIMPOSED GRATING WDM TUNABLE LASERS	CA	2,228,683	2,228,683			SUPERIMPOSED GRATING WDM TUNABLE LASERS
HQ0054	SUPERIMPOSED GRATING WDM TUNABLE LASERS	US	09/253,129	6,141,370			SUPERIMPOSED GRATING WDM TUNABLE LASERS

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ID0032		US	08/319,435	5,534,44			OPTO ELECTRONIC COMPONENTS
ID0079	SEMICONDUCTOR - SLICE CLEAVING	GB	9216363.3	2 269 26	В		SEMICONDUCTOR - SLICE CLEAVING
ID0079	SEMICONDUCTOR - SLICE CLEAVING	US	08/093,766	5,393,70	7		SEMICONDUCTOR - SLICE CLEAVING
ID0094	HYBRID OPTIC SOLUTION	V DE	95307824.3	695 04 280.7			HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	V FR	95307824.3	0 713 27			HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	√ GB	9423282.4	2 295 265	5		HYBRID OPTIC SOLUTION
1D0094	HYBRID OPTIC SOLUTION	V JP	293046/1995				HYBRID OPTIC SOLUTION
ID0094	HYBRID OPTIC SOLUTION	us	08/560,312	5,668,823			HYBRID OPTIC SOLUTION
ID0134	SEMICONDUCTOR ETCHING PROCESS	FR	94301114.8	0 614 214			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	GB	94301114.8	0 614 214			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	DE	69401370.6	69401370.	6		SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	GB	9303257.1	2 275 364			SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	JP	6-45068				SEMICONDUCTOR ETCHING PROCESS
ID0134	SEMICONDUCTOR ETCHING PROCESS	US	08/197,071	5,419,804			SEMICONDUCTOR ETCHING PROCESS
ID0137	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	GB	9417975.1	2 293 248			PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID0137	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS	US	08/507,613	5,574,811		·	PROVIDING OPTICAL COUPLING BETWEEN OPTICAL COMPONENTS
ID0170	INJECTION LASER AND PHOTOSENSOR ASSEMBLY	US	08/201,473	5,365,534			INJECTION LASER AND PHOTOSENSOR ASSEMBLY
ID0193	FILAMENT COOLER	GB	9404290.0	2 287 244			FILAMENT COOLER
ID0193	FILAMENT COOLER	us	08/388,151	5,568,728			FILAMENT COOLER
ID0199	CO & COUNTER-PUMPED OPTICAL AMPLIFIER	us	08/303,367	5,542,011			CO & COUNTER-PUMPED OPTICAL AMPLIFIER
1D0206	ELECTRO ABSORPTION OPTICAL MODULATORS	US	08/303,374	5,530,580			ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS	EP	94306216.6	0 643 317	Nat'l Phase Filed	E	ELECTRO ABSORPTION OPTICAL MODULATORS
ID0206	ELECTRO ABSORPTION OPTICAL MODULATORS	GB	9417001.6	2 281 785		E	ELECTRO ABSORPTION OPTICAL MODULATORS

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9 No					Slatos	Deput/Os	
ID020	06 ELECTRO ABSORPTIO OPTICAL MODULATOR		94306216.6	694 26 796.1	3		ELECTRO ABSORPTION OPTICAL MODULATORS
ID020	6 ELECTRO ABSORPTIO OPTICAL MODULATOR		94306216.6	0 643 31	17		ELECTRO ABSORPTION OPTICAL MODULATORS
ID020	6 ELECTRO ABSORPTIO OPTICAL MODULATOR		216309/94				ELECTRO ABSORPTION OPTICAL MODULATORS
ID021	PROVIDING OPTICAL COUPLING WITH SINGL CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	E	94305060.9	694 10 032.3			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS		94305060.9	0 636 912	2		PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS		9315789.9	2 280 544	1		PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	GB	94305060.9	0 636 912			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	JP	180288/94				PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0216	PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO- OPTIC TRANSDUCERS	US	08/283,264	5,522,000			PROVIDING OPTICAL COUPLING WITH SINGLE CRYSTAL SUBSTRATE MOUNTED ELECTRO-OPTIC TRANSDUCERS
ID0237	DIRECT AMPLITUDE MODULATION OF LASERS	us	08/216,301	5,502,741			DIRECT AMPLITUDE MODULATION OF LASERS
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	EP	96301377.6	0 732 739	Nat'l Phase Filed		IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	JP	52013/96				IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	US	08/612,314	5,933,707			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	GB	96301377.6	0 732 739			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING
ID0261	IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING	DE	96301377.6	696 18 264.5			IMPROVEMENTS IN CRYSTAL SUBSTRATE PROCESSING

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ID0261		FI	96301377.6	0 732 73		IMPROVEMENTS IN CRYSTA SUBSTRATE PROCESSING	
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	Di	195 28 165.9			POLARISATION-INSENSITIV OPTICAL MODULATORS	Έ
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	GI	9515400.1	2 291 97	9	POLARISATION-INSENSITIV OPTICAL MODULATORS	E
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	FF	9509417	2723485		POLARISATION-INSENSITIVI OPTICAL MODULATORS	E
ID0287	POLARISATION- INSENSITIVE OPTICAL MODULATORS	US	08/510,752	6,275,321		POLARISATION-INSENSITIVE OPTICAL MODULATORS	Ē
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	EP	95308872.1	0 717 297	Nat'l Phase Filed	OPTICALLY COUPLING OPTICATION LASER	
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GB	9425022.2	2 296 101		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASER	
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	US	08/570,983	5,570,444		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASER	
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	DE	95308872.1	695 26 563.6		OPTICALLY COUPLING OPTICA FIBRES TO INJECTION LASER	
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	GB	95308872.1	0 717 297		OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	AL S
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	FR	95308872.1	0 717 297		OPTICALLY COUPLING OPTICA FIBRES TO INJECTION LASERS	
ID0295	OPTICALLY COUPLING OPTICAL FIBRES TO INJECTION LASERS	ΙΤ	95308872.1	0 717 297		OPTICALLY COUPLING OPTICA FIBRES TO INJECTION LASERS	
ID0311	OPTICAL AMPLIFIER	DE	96308900.8	696 03 935.4		OPTICAL AMPLIFIER	┪
ID0311	OPTICAL AMPLIFIER	EP	96308900.8		Nat'l Phase Filed	OPTICAL AMPLIFIER	\exists
ID0311	OPTICAL AMPLIFIER	П	96308900.8	0 779 689		OPTICAL AMPLIFIER	\dashv
ID0311	OPTICAL AMPLIFIER	FR	96308900.8	0 779 689		OPTICAL AMPLIFIER	7
ID0311	OPTICAL AMPLIFIER	GB	9525766.3	2 308 222		OPTICAL AMPLIFIER	1
ID0311	OPTICAL AMPLIFIER	US	08/760,175	5,872,649		OPTICAL AMPLIFIER	7
ID0348	LASERS	EB	PCT/GB96/01406		Nat'i Phase Filed	LASERS	1
ID0384	HERMETIC OPTICAL FIBRE FEED-THROUGH	GB	9515004.1	2 303 467		HERMETIC OPTICAL FIBRE FEED THROUGH	7
ID0384	HERMETIC OPTICAL FIBRE FEED-THROUGH	US	08/684,128	5,664,043		HERMETIC OPTICAL FIBRE FEEL THROUGH	7

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ID0426	ETALON ARRANGEMENT	F EP	97305110.5		Siauss	As Depontos	ETALON ARRANGEMENT
ID0426	ETALON ARRANGEMENT	JP	179766/1997				ETALON ARRANGEMENT
ID0426	ETALON ARRANGEMENT	JP	179766/1997				ETALON ARRANGEMENT
ID0426	ETALON ARRANGEMENT	CA	2,203,845	2,203,845			ETALON ARRANGEMENT
ID0426	ETALON ARRANGEMENT	<u> </u>	08/848,337	5,828,689			ETALON ARRANGEMENT
ID0431	SEMICONDUCTOR LASERS	DE	97901693.8	697 00 830.4			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	EP	97901693.8	0 876 696	Nat'l Phase Filed		SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	FR	97901693.8	0 876 696		,	SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	GB	9601703.3	2 309 581			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	GB	97901693.8	0 876 696			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	IT	97901693.8	0 876 696			SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	JP	526680/1997				SEMICONDUCTOR LASERS
ID0431	SEMICONDUCTOR LASERS	US	09/091,684	6,058,125			SEMICONDUCTOR LASERS
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	EP	97902473.4	0 879 435	Nat'l Phase Filed		SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	GB	9602564.8	2 310 052			CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	JP	528272/1997				CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	US	08/952,676	5,985,086			CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	DE	97902473.4	697 10 047.2		S	SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	TT	97902473.4	0 879 435		s	SECURING AN OPTICAL FIBRE IN A V-GROOVE

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ID046				0 879 435			SECURING AN OPTICAL FIBRE IN A V-GROOVE
ID0467	7 CONTROLLED DISPENS OF GLUE ONTO A SILICON V-GROOVE SUBSTRATE	EWC	PCT/GB97/0032	0	Nat'i Phas Filed	е	CONTROLLED DISPENSE OF GLUE ONTO A SILICON V- GROOVE SUBSTRATE
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	JP	507707/1998				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	US	09/214,634	6,188,118			SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	CA	2,258,178				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	EP	97933796.1				SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0519	SEMICONDUCTOR PHOTODETECTOR PACKAGING	WO	PCT/GB97/02053		Nat'l Phase Filed		SEMICONDUCTOR PHOTODETECTOR PACKAGING
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	EP	98303274.9				DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	US	08/865,760	5,901,164			DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	CA	2,235,179				DIRECT AMPLITUDE MODULATION OF LASERS
ID0651	DIRECT AMPLITUDE MODULATION OF LASERS	JP	146072/1998				DIRECT AMPLITUDE MODULATION OF LASERS
ID0687	OPTICAL TRANSMITTER OUTPUT MONITORING TAP	US	08/984,894	6,124,956			OPTICAL TRANSMITTER OUTPUT MONITORING TAP
ID0691	BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATES	US	09/072,810	6,075,800		ı	BONDING RIDGE STRUCTURE LASER DIODES TO SUBSTRATES
ID0764	A REMOVABLY COATED OPTICAL FIBRE	US	09/374,807	6,351,589			REMOVABLY COATED OPTICAL FIBRE
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	EP	98309206.5		·		ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	JР	365470/1998			Ē	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	US	08/997,752	5,956,437		E	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR
ID0803	ELECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR	CA	2,254,148				CLECTRICALLY CONTROLLABLE OPTICAL ATTENUATOR

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1D0908	SEMICONDUCTOR OPTO ELECTRONIC DEVICE PACKAGING	US	09/070,899	6,407,438			SEMICONDUCTOR OPTO- ELECTRONIC DEVICE PACKAGING
ID1107	INTEGRATED OPTICAL MACH ZENDER STRUCTURES	EP	00301124.4				INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES
ID1107	INTEGRATED OPTICAL MACH ZENDER STRUCTURES	US	09/280,360	6,240,221			INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES
ID1107	INTEGRATED OPTICAL MACH ZENDER STRUCTURES	CA	2,299,794				INTEGRATED OPTICAL MACH ZEHNDER STRUCTURES
ID8512	INJECTION LASER PACKAGES	US	06/514,066	4,615,031			INJECTION LASER PACKAGES
ID8512	INJECTION LASER PACKAGES	GB	8317959	2 124 402			INJECTION LASER PACKAGES
ID8850	OPTICAL AMPLIFIERS	US	06/888,274	4,720,684		· · · · · · · · · · · · · · · · · · ·	OPTICAL AMPLIFIERS
ID8850	OPTICAL AMPLIFIERS	CA	469,211	1,245,328			OPTICAL AMPLIFIERS
ID8852	MANUFACTURING OPTICAL FIBRE	US	06/736,327	4,608,276			MANUFACTURING OPTICAL FIBRE
ID8852	MANUFACTURING OPTICAL FIBRE	CA	482,229	1,261,632		***	MANUFACTURING OPTICAL FIBRE
ID8960	OPTICAL FIBRE MANUFACTURE	US	06/940,232	4,735,648			OPTICAL FIBRE MANUFACTURE
ID9003	COATING OPTICAL FIBRES	DE	85306977.1	356 83 25.2			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	JP	222908/85	2029150			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	US	06/782,930	4,631,078			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	GB	85306977.1	0 178 107			COATING OPTICAL FIBRES
ID9003	COATING OPTICAL FIBRES	CA	492,574	1,226,411			COATING OPTICAL FIBRES
ID9186	LASER MANUFACTURE	us	07/296,946	4,949,352			LASER MANUFACTURE
ID9186	LASER MANUFACTURE	GB	8512321	2 175 442			LASER MANUFACTURE
ID9209	TUBE FURNACE	US	06/858,617	4,748,307			TUBE FURNACE
ID9312	OPTICAL FIBRE MANUFACTURE	US	06/896,518	4,793,840			OPTICAL FIBRE MANUFACTURE
ID9312	OPTICAL FIBRE MANUFACTURE	GB	8520945	2 179 339			OPTICAL FIBRE MANUFACTURE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	DE	365 02 56.1	365 02 56.1			OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID9315	OPTICAL FIBRE CABLE HAVING SLOTTED CORE	FR	86306868.0	0 216 548			OPTICAL FIBRE CABLE HAVING SLOTTED CORE

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10931	5 OPTICAL FIBRE CABL HAVING SLOTTED COR	E GI	B 86306868.	0 216 548			OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID931	HAVING SLOTTED COF	RE	217514	217514			OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID931	HAVING SLOTTED COF		07/636,902	RE34,516			OPTICAL FIBRE CABLE HAVING SLOTTED CORE
ID937	INTEGRATED OPTICAL DEVICE COUPLER	L	06/934,440	4,772,086			OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9379	OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER	GB	8530797	2 184 255			OPTICAL FIBRE INTEGRATED OPTICAL DEVICE COUPLER
ID9495		DE	87302417.8	376 44 10.6			LASER ARRAY
ID9495		JP	129591/87	2511969			LASER ARRAY
ID9495		US	07/032,779	4,760,580			LASER ARRAY
ID9552		ı	3883556.8	3883556.8			OPTICAL FIBRE CABLES
ID9552			88300817.9	0 278 648			OPTICAL FIBRE CABLES
ID9552		J	8703255	2 201 008			OPTICAL FIBRE CABLES
ID9552	OPTICAL FIBRE CABLES		07/154,866	4,830,459			OPTICAL FIBRE CABLES
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	DE	88306994.0	388 13 01.7			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	FR	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	8719590	2 208 944			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	GB	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	NL	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	SE	88306994.0	0 304 182			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9604	FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER	US	07/230,057	4,988,159			FIBRE TAILED OPTO- ELECTRONIC TRANSDUCER
ID9617	EDGE EMITTING LIGHT EMISSIVE DIODE	US	07/239,403	4,937,638		E	DGE EMITTING LIGHT EMISSIVE DIODE
ID9661	WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER	GB	8823873.8	2 213 957			WAVEGUIDE TO OPTO- ELECTRONIC TRANSDUCER
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ID9715	CONTACTLESS MEASUREMENT OF TH ELECTRICAL RESISTANCE PER UNIT LENGTH	FF	90305474.0	0 400 853	3	CONTACTLESS I OF THE EL RESISTANCE PER	ECTRICAL
ID9715	CONTACTLESS MEASUREMENT OF THI ELECTRICAL RESISTANCE PER UNIT LENGTH	GB	8912458.0	2 232 260		CONTACTLESS NOF THE ELE RESISTANCE PER	ECTRICAL
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	JP	141220/1990	2991238		CONTACTLESS M OF THE ELE RESISTANCE PER	CTRICAL
ID9715	CONTACTLESS MEASUREMENT OF THE ELECTRICAL RESISTANCE PER UNIT LENGTH	US	07/531,791	5,083,090		CONTACTLESS M OF THE ELE RESISTANCE PER	CTRICAL I
ID9716	CARB ON COATING OF OPTICAL FIBRES	DE	690 10 282.8	0 400 938		CARB ON COATIN	
ID9716	CARB ON COATING OF OPTICAL FIBRES	FR	90305776.8	0 400 938		CARB ON COATIN	
ID9716	CARB ON COATING OF OPTICAL FIBRES	GB	9011933.0	2 236 331		CARB ON COATING	
ID9716	CARB ON COATING OF OPTICAL FIBRES	JР	141221/1990	2866707		CARB ON COATING	
ID9716	CARB ON COATING OF OPTICAL FIBRES	US	07/531,859	5,062,687		CARB ON COATING FIBRE	
ID9731	BONDING A SEMICONDUCTOR TO A SUBSTRATE	GB	8818522.8	2 221 570		BONDING A SEMIO TO A SUBS	
ID9742	OPTICAL FILTERS	GB	8823078.4	2 223 324		OPTICAL FII	LTERS
ID9750	DIFFRACTION GRATING	DE	68928711.9	0365125		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	FR	89308702.3	0 365 125		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	GB	8821898.7	2 222 891		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	п	22874/BE/98	0 365 125		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION (i
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	JP	239789/1989	2889608		DIFFRACTION	GRATING
ID9750	DIFFRACTION GRATING	us	07/579,081	5,029,981		DIFFRACTION	BRATING

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ID975					B B Status	e iegonolos i	
ID975	DIFFRACTION GRATIN	IG J	239789/1989				DIFFRACTION GRATING
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ID975	0 DIFFRACTION GRATIN	G NI	89308702.3	0 365 12	25		DIFFRACTION GRATING
ID975	2 VAPOUR PHASE PROCESSING	GE	8823233.5	2 223 50	9		VAPOUR PHASE PROCESSING
ID976	MULTICHANNEL CAVIT LASER	Y DE	89312024.6	689 18 238.4			MULTICHANNEL CAVITY LASEF
ID9763	MULTICHANNEL CAVIT LASER	YFR	89312024.6	0 370 73	9		MULTICHANNEL CAVITY LASER
ID9763	MULTICHANNEL CAVITY	Y GB	8827385.9	2 225 482	2		MULTICHANNEL CAVITY LASER
ID9763	MULTICHANNEL CAVITY LASER	r us	07/625,818	5,115,444	4		MULTICHANNEL CAVITY LASER
ID9774	INTEGRATED OPTICS ASYMMETRIC Y- COUPLER	GB	8902391.5	2 227 854			INTEGRATED OPTICS ASYMMETRIC Y-COUPLER
ID9806	OPTICAL FIBRE CABLE	US	07/544,678	5,082,380	-		OPTICAL FIBRE CABLE
ID9837	AERIAL OPTICAL FIBRE CABLE	us	07/596,381	5,050,960			AERIAL OPTICAL FIBRE CABLE
ID9856	SEMICONDUCTOR OPTICAL SOURCE	GB	8924725.8	2 237 654			SEMICONDUCTOR OPTICAL SOURCE
ID9870	RING LASER	FR	90309362.3	0 419 059			RING LASER
ID9870	RING LASER	GB	8921295.5	2 236 426			RING LASER
ID9870	RING LASER	DE	69003780.5	0 419 059	 -		RING LASER
ID9870	RING LASER	JP	249922/1990	3004336			RING LASER
ID9870	RING LASER	US	07/583,590	5,056,096			
MO0068	OPTICAL WAVEGUIDE	FR	90304772.8	0401971			RING LASER
	AND METHOD FOR ITS MANUFACTURE		30304772.6	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	CA	2,013,849	2,013,849			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	DE	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	EP	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	US	07/363,006	4,934,774			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE

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MO0068	B OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	US	07/501,990	5,035,916			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0068	B OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE	GB	90304772.8	0401971			OPTICAL WAVEGUIDE AND METHOD FOR ITS MANUFACTURE
MO0166	A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM AN OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER		08/710,775	5,703,980			A METHOD FOR LOW LOSS INSERTION OF AN OPTICAL SIGNAL FROM A OPTICAL FIBER TO A WAVEGUIDE INTEGRATED ONTO A SEMICONDUCTOR WAFER
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		2,209,548				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		97111629.8				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	4 1	9-185588				A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		08/677,922	5,793,913			A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE		09/079,480	6,158,901			A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
MO0167	A METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE	US	09/584,792	6,391,214			METHOD FOR THE HYBRID INTEGRATION OF DISCRETE ELEMENTS ON A SEMICONDUCTOR SUBSTRATE
RE1009	FIBER OPTIC COUPLER	CA	476,580	1,258,787			FIBER OPTIC COUPLER
RE1009	FIBER OPTIC COUPLER	US	07/442,878	4,950,046			FIBER OPTIC COUPLER
RE1037	OPTICAL SIGNAL MODULATORS	CA	507,411	1,257,923			OPTICAL SIGNAL MODULATORS
RE1037	OPTICAL SIGNAL MODULATORS	US	06/856,887	4,730,171			OPTICAL SIGNAL MODULATORS
RO1624	HERMETIC OPTICAL ATTENUATOR	US	06/233,500	4,695,125			HERMETIC OPTICAL ATTENUATOR

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RO180	07 DIFFUSION EQUIPMEN	T CA	416.834	1,204,986	Saus	Deputyos	DIFFUSION EQUIPMENT
RO180	DIFFUSION EQUIPMEN	TUS					
				4,493,287			DIFFUSION EQUIPMENT
RO180	A PLANAR NARROW- STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT	us	06/448,383	4,530,099			A PLANAR NARROW-STRIPE LASER WITH IMPROVED CHARGE CARRIER CONFINEMENT
RO188	2 MELT DISPENSING LIQUID PHASE EPITAXY BOAT	CA	448,169	1,201,220			MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO188	2 MELT DISPENSING LIQUID PHASE EPITAXY BOAT	/ US	06/583,985	4,574,730			MELT DISPENSING LIQUID PHASE EPITAXY BOAT
RO190	3 METHOD FOR SCREENING LASER DIODES	CA	447,814	1,196,080			METHOD FOR SCREENING LASER DIODES
RO190	METHOD FOR SCREENING LASER DIODES	US	06/582,956	4,489,477			METHOD FOR SCREENING LASER DIODES
RO1944	PHASED LINEAR LASER ARRAY	CA	465,981	1,238,707	·		PHASED LINEAR LASER ARRAY
RO1944	PHASED LINEAR LASER ARRAY	US	06/663,424	4,661,962			PHASED LINEAR LASER ARRAY
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	CA	495,084	1,290,656	·		ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1961	ZINC DIFFUSION INTO INDIUM PHOSPHIDE	US	07/243,138	4,889,830			ZINC DIFFUSION INTO INDIUM PHOSPHIDE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	CA	483,077	1,238,973			DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1987	DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE	US	06/673,644	4,660,207			DOUBLE HETEROSTRUCTURE SURFACE EMITTING LASER STRUCTURE
RO1994	A SURFACE EMITTING LASER	CA	474,029	1,238,971			A SURFACE EMITTING LASER
RO1994	A SURFACE EMITTING LASER	US	06/701,839	4,675,877			A SURFACE EMITTING LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	US	06/701,707	4,675,876			A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER
RO2005	A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER	CA	474,030	1,238,972			A BRAGG DISTRIBUTED FEEDBACK SURFACE EMITTING LASER
RO2268	AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE	CA	562,885	1,293,179		A	IN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE
RO2268	AN INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE	US	07/179,834	4,859,628		A	N INTERRUPTED LIQUID PHASE EPITAXY TECHNIQUE

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RO2314		US		4,847,665	Status	Zept No S	MONOLITHIC INTEGRATION OF OPTOELECTRONIC AND ELECTRONIC DEVICES
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	US	07/201,155	4,849,373			GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2349	GROWTH OF SEMI- INSULATING INP BY LIQUID PHASE EPITAXY	CA	568,369	1,313,107			GROWTH OF SEMI-INSULATING INP BY LIQUID PHASE EPITAXY
RO2461	OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION	US	07/369,883	4,969,712			OPTOELECTRONIC APPARATUS AND METHOD FOR ITS FABRICATION
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	CA	2,018,900	2,018,900			PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2468	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE	US	07/385,599	4,953,006		Land Land Land Land Land Land Land Land	PACKAGING METHOD AND PACKAGE FOR EDGE COUPLED OPTOELECTRONIC DEVICE
RO2564	LASER DIODE STRUCTURE	FR	91908207.3	0 530 212			LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	DE	91908207.3	691 07 845.9			LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	GB	91908207.3	0 530 212	·		LASER DIODE STRUCTURE
RO2564	LASER DIODE STRUCTURE	US	07/522,015	4,989,214		T-T	LASER DIODE STRUCTURE
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	US	07/582,464	5,050,953			MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER
RO2579	MULTICHANNEL FIBER OPTIC TRANSMITTER RECEIVER	GB	91185124	2 248 968			MULTICHANNEL FIBER OPTIC TRANSMITJER RECEIVER
RO2714	APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS	US	07/996,411	5,350,923			APPARATUS FOR USE WITH ANALYTICAL MEASURING INSTRUMENTS
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	DE	94915483.5	694 08 144.2			OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	FR	94915483.5	0 708 930		·	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION

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NO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	GB	94915483.5	0 708 930		Pom Nois	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION	JP	7-504252-95	2691638			OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2785	MODULATING DEVICES AND METHODS FOR THEIR OPERATION	US	08/091,708	5,363,457			OPTICAL PHASE MODULATING DEVICES AND METHODS FOR THEIR OPERATION
RO2788	METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES		08/118,273	5,345,459	•		METHOD OF REDUCING THE THERMALLY INDUCED SHIFT IN THE EMISSION WAVELENGTH OF LASER DIODES
RO2799	GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION	US	08/170,074	5,452,318			GAIN COUPLED DFB LASER WITH INDEX COUPLING COMPENSATION
RO2809	METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES	US	08/158,545	5,586,207			METHODS AND ASSEMBLIES FOR PACKAGING ELECTRONIC DEVICES AND FOR COUPLING OPTICAL FIBERS TO THE PACKAGED DEVICES
RO2817	CIRCULAR GRATING LASERS	US	08/158,543	5,448,581			CIRCULAR GRATING LASERS
RO2875	CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING	US	08/450,841	5,524,076			CHIRP CONTROL OF A MACH ZEHNDER OPTICAL MODULATOR USING NON EQUAL POWER SPLITTING
	SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE	US	08/242,653	5,483,547			SEMICONDUCTOR LASER STRUCTURE FOR IMPROVED STABILITY OF THE THRESHOLD CURRENT WITH RESPECT TO CHANGES IN AMBIENT TEMPERATURE
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	GB	9513146.2	2 302 738			SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	JP	8-188293				SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT
RO2956	SEMICONDUCTOR MODULATOR WITH A 2-2 SHIFT	CA	2,176,099	2,176,099			SEMICONDUCTOR MODULATOR WITH A SHIFT

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GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MA	RO296	PATTERNS IN III-V MATERIAL WITH ACCURATE	US	08/450,839	5,567,659			PATTERNS IN III-V MATERIAL WITH ACCURATE
STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 RO2991 RO2991 RO2991 RO2991 RO2992 RO2992 RO2993 RO2993 RO2993 RO2994 RO2994 RO2994 RO2995 RO3995 RO3999 RO3995 RO3995 RO3999 RO3995 RO3995 RO3999 RO3999 RO3999 RO3999 RO3995 RO3999 RO39	RO2974	GAIN COUPLED DISTRIBUTED FEEDBACE LASER ARRAY WITH FINE	1	08/413,555	5,536,085			MULTI WAVELENGTH GAIN COUPLED DISTRIBUTED FEEDBACK LASER ARRAY WITH FINE TUNABILITY
STRONGLY AND WEAKLY GUIDING WAYEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAYEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAYEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAYEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAYEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO3007 BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS	RO2999	STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER	'	2,209,455				COMPACT INTEGRATED MACH
STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO2999 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS US 08/675,757 5,799,119 COUPLING OF STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO3007 BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS	RO2999	STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER		97304743.4				COMPACT INTEGRATED MACH
STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER MODULATORS RO3007 BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS RO3015 THIN FILM RESISTOR US 08/977,371 5,960,014	RO2999	STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER		9-174942				COMPACT INTEGRATED MACH
HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKING LAYER RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS RO3015 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKI G LAYER THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS RO3015 THIN FILM RESISTOR US 08/977,371 5,960,014 THIN FILM RESISTOR FOR THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS	RO2999	STRONGLY AND WEAKLY GUIDING WAVEGUIDES FOR COMPACT INTEGRATED MACH ZEHNDER	US	08/675,757	5,799,119		ž	COMPACT INTEGRATED MACH
FOR OPTOELECTRONIC INTEGRATED CIRCUITS RO3015 THIN FILM RESISTOR JP 9-009795 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS RO3015 THIN FILM RESISTOR US 08/977,371 5,960,014 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS	RO3007	HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT	US	08/728,991	6,028,875			BURIED HETEROSTRUCTURE LASER WITH QUATERNARY CURRENT BLOCKI G LAYER
FOR OPTOELECTRONIC INTEGRATED CIRCUITS RO3015 THIN FILM RESISTOR US 08/977,371 5,960,014 THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATE CIRCUITS	RO3015	FOR OPTOELECTRONIC	GB	9700985.6	2 309 335			OPTOELECTRONIC INTEGRATED
	RO3015	FOR OPTOELECTRONIC	JP	9-009795				OPTOELECTRONIC INTEGRATED
COD COTOCI ECTOCATIO	RO3015	FOR OPTOELECTRONIC	US	08/977,371	5,960,014		(THIN FILM RESISTOR FOR OPTOELECTRONIC INTEGRATED CIRCUITS
RO3066 LASER DIODE AND METHOD OF FABRICATION THEREOF BO3066 LASER DIODE AND METHOD OF FABRICATION THEREOF		METHOD OF	US	09/093,399	6,151,347			LASER DIODE AND METHOD OF FABRICATION THEREOF

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RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	CA	2,220,240	2,220,240		Depth No.5 Mark	CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	EP	97308615.0				CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	US	08/745,168	5,778,113			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3090	CONFIGURABLE CHIRP MACH-ZEHNDER OPTICAL MODULATOR	US	09/057,602	5,991,471			CONFIGURABLE CHIRP MACH- ZEHNDER OPTICAL MODULATOR
RO3092	POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE	US	08/686,355	5,777,793			POLARIZATION INSENSITIVE MULTILAYER PLANAR REFLECTION FILTERS WITH NEAR IDEAL SPECTRAL RESPONSE
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	CA	2,209,558				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	EP	97111630.6	0 818 859	Nat'l Phase Filed		WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	US	08/680,284	5,825,792			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	JP	9-186204				WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	GB	97111630.6	0 818 859			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	DE	97111630.6	697 11 126.1			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS
RO3139	WAVELENGTH MONITORING AND. CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS	FR	97111630.6	0 818 859			WAVELENGTH MONITORING AND CONTROL ASSEMBLY FOR WDM OPTICAL TRANSMISSION SYSTEMS

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RO3478	TWO SECTION COMPLE: COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASE: WITH ENHANCED		98307439.4				TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH
	WAVELENGTH TUNING RANGE						ENHANCED WAVELENGTH TUNING RANGE
RO3478	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASEI WITH ENHANCED WAVELENGTH TUNING RANGE		10-264323				TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3478	TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASEF WITH ENHANCED WAVELENGTH TUNING RANGE		08/933,529	5,936,994			TWO SECTION COMPLEX COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH ENHANCED WAVELENGTH TUNING RANGE
RO3479	DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION		08/953,015	6,026,110			DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER WITH GAIN MODULATION
RO3610	COMPLEX COUPLED DFB LASERS		98310111.4				SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS		10-366380				SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3610	SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS	US	08/998,071	6,104,739			SERIES OF STRONGLY COMPLEX COUPLED DFB LASERS
RO3746	ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION	US	08/994,453	5,869,398			ETCHING OF INDIUM PHOSPHIDE MATERIALS FOR MICROELECTRONICS FABRICATION
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	wo	PCT/CA99/01067				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	CA	2,310,604				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	EP	99973441.1				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER
RO3920	HIGH ORDER GAIN COUPLED DFB LASERS	JP	2000-588867				A GAIN COUPLED DISTRIBUTED FEEDBACK SEMICONDUCTOR LASER

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RO4144	COMPACT PROGRAMMABLE MATRIX OF STRONGLY COMPLEX COUPLED DFE LASERS FOR WIDE AND CONTINUOUS SINGLE WAVELENGTH		09/209,860	6,201,824			STRONGLY COMPLEX COUPLED DFB LASERS SERIES
RO4324	CONTINUOUSLY TUNABLE HIGH REPETITION RATE SHORT PULSE GENERATION USING DUAL MODE HIGHLY GAIN-COUPLED DFB LASER DIODES	US	09/213,088				GENERATION OF SHORT OPTICAL PULSES USING STRONGLY COMPLEX COUPLED DFB LASERS
RO4416	VARIABLE OPTICAL ATTENUATOR	US	09/388,628	6,246,826			VARIABLE OPTICAL ATTENUATOR WITH PROFILED BLADE
RO4504	ACTIVE REFLECTION MODULATOR	US	09/409,036				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR		PCT/CA00/00856	_	Nat'l Phase Filed		COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	CA	2,351,381				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	EP	947728.2				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM
RO4504	ACTIVE REFLECTION MODULATOR	JP	2001-527411				COMPOUND CAVITY REFLECTION MODULATION LASER SYSTEM

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10163ID	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES	CA	2,311,961		SLOTTED MONOLITHIC OPTICAL WAVEGUIDE
10163ID	OPTICAL WAVEGUIDES	EP	304657		PHASE ADJUSTER USING SLOTTED, CONCATENATED WAVEGUIDES AND THERMO OPTIC OR ELECTRO-OPTIC INSERTS
10163ID	SLOTTED MONOLITHIC OPTICAL WAVEGUIDES	US	09/346,320	6,424,755	SLOTTED MONOLITHIC OPTICAL WAVEGUIDE
11550RC	HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH	CA	2,355,450		HYBRID ATTACH MIRRORS FOR A MEMS OPTIC SWITCH
11550RO	HYBRID ATTACH MIRRORS FOR A MEMS OPTICAL SWITCH	US	09/672,703		HYBRID ATTACH MIRRORS FOR A MEMS OPTIC SWITCH
12801AU	FIBRE OPTIC CIRCULATOR	EP	96940631.3		FIBRE OPTIC CIRCULATOR
12801AU	FIBRE OPTIC CIRCULATOR	US	08/942,601	6,014,475	FIBRE OPTIC CIRCULATOR
	OPTICAL FILTERING METHOD AND DEVICE		2,318,674		OPTICAL FILTERING METHOD AND DEVICE
12802AU	OPTICAL FILTERING METHOD AND DEVICE	US	09/660,147	6,466,704	OPTICAL FILTERING METHOD AND DEVICE
12802AU	OPTICAL FILTERING METHOD AND DEVICE	wo	PCT/AU00/00735		OPTICAL FILTERING METHOD AND DEVICE
12803AU	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	CA	2,313,311		REFLECTIVE NON RECIPROCAL OPTICAL DEVIC
12803AÜ	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	EP	202289.5		REFLECTIVE NON RECIPROCAL OPTICAL DEVIC

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12803AU	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	US	09/345,027	6,263,131		REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12803AU	REFLECTIVE NON RECIPROCAL OPTICAL DEVICE	US	09/610,601	6,415,077		REFLECTIVE NON-RECIPROCAL OPTICAL DEVICE
12804AL	WAVELENGTH DEPENDENT ISOLATOR	CA	10/129828		Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
12804AL	WAVELENGTH DEPENDENT ISOLATOR	US	PCT/AU00/01380		Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
12804AU	WAVELENGTH DEPENDENT ISOLATOR	wo	PCT/AU00/01380	<u> </u>	Nat'l Phase Filed	WAVELENGTH DEPENDENT ISOLATOR
13240AU	POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE	US	09/736,095			POLARISATION SPLITTING CIRCULATOR METHOD AND DEVICE
14081ID	FIBRE OPTICAL COMPONENT	US	09/888,888			FIBRE OPTICAL COMPONENT
14669AU	VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE	US	10/218,267			VARIABLE ATTENUATION AND SPECTRAL SLOPE OPTICAL DEVICE
15087ID	AN OPTICAL GRATING DEVICE	US	10/109,916			AN OPTICAL GRATING DEVICE
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	DE	95308065.2	695 27 251.9		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	EP	95308065.2	0 713 109	Nat'l Phase Filed	WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	FR	95308065.2	0 713 109		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	GB	9521916.8	2 295 245		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	JP	293047/1995			WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0190	WAVELENGTH RESONANT FUSED FIBRE COUPLER	US	08/557,857	5,703,976		WAVELENGTH RESONANT FUSED FIBRE COUPLER
ID0226	OPTICAL WAVEGUIDE GRATINGS	GB	9318670.8	2 281 787		OPTICAL WAVEGUIDE GRATINGS
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	DE	95308201.3	695 25 223.2		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	EP	95308201.3	0 713 110	Nat'l Phase Filed	OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	FR	95308201.3	0 713 110		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	GB	9523489.4	2 295 247		OPTICAL WAVEGUIDE GRATING FILTER
ID0291	OPTICAL WAVEGUIDE GRATING FILTER	US	08/558,709	5,638,473		OPTICAL WAVEGUIDE GRATING FILTER
ID0309	BRAGG GRATINGS IN WAVEGUIDES	US	08/647,795	5,730,888		BRAGG GRATINGS IN WAVEGUIDES
ID0355	ALL-FIBRE OPTICAL FILTER	DE	96302352.8	696 22 778.9		OPTICAL NOTCH FILTER MANUFACTURE
ID0355	ALL-FIBRE OPTICAL FILTER	EP	96302352.8	0 736 784	Nat'l Phase Filed	OPTICAL NOTCH FILTER MANUFACTURE

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ID0355						OPTICAL NOTCH FILTER MANUFACTURE
		GB	96302352.8	0 736 78	4	OPTICAL NOTCH FILTER MANUFACTURE
ID0355		US	08/628,579	5,708,740)	ALL-FIBRE OPTICAL FILTER
ID0421	PLANAR WAVEGUIDES	US	08/842,021	5,904,49		PLANAR WAVEGUIDES
ID0423	PLANAR WAVEGUIDE CLADDING	US	08/842,022	5,885,881		PLANAR WAVEGUIDE CLADDING
1D0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	CA	2,241,189			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	DE	97906822.8	697 09 330.1		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	EP	97906822.8	0 891 570	Nat'l Phas Filed	e WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	FR	97906822.8	0 891 570	·	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	9605320.2	2 311 145		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	GB	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	ΙΤ	97906822.8	0 891 570		WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	JP	532348/1997			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	US	09/101,276			WAVEGUIDES TO PHOTODETECTOR ASSEMBLY
ID0444	WAVEGUIDES TO PHOTODETECTOR ASSEMBLY	wo	PCT/GB97/00606		Nat'l Phase Filed	WAVEGUIDES TO PHOTODE/ECTOR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	CA	2,239,118			WAVEGUIDE PAIR WITH CLADDING
ID0449	WAVEGUIDE PAIR WITH CLADDING	DE	97900292	697 02 299.4	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	EP	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	FR	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY
ID0449	WAVEGUIDE PAIR WITH CLADDING	GB	97900292	0 873 531	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUIDE PAIR ASSEMBLY

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ID04	49 WAVEGUIDE PAIR WITH CLADDING	IT	97900292	0 873 53	Nat'l Phase Filed	METHOD OF PRODUCING A CLADDED WAVEGUID PAIR ASSEMBLY
ID044	WAVEGUIDE PAIR WITH CLADDING	JP	524974/199	7		WAVEGUIDE PAIR WITH CLADDING
ID044	WAVEGUIDE PAIR WITH CLADDING	US	09/091,257	6,044,19	2	WAVEGUIDE PAIR WITH CLADDING
ID044	9 WAVEGUIDE PAIR WITH CLADDING	wo	PCT/GB97/000	940	Nat'l Phase Filed	WAVEGUIDE PAIR WITH CLADDING
ID050	9 MANUFACTURE OF PLANA WAVEGUIDE COMPONENT WITH DISPERSIVE ELEMENTS AND FINE LOCA REF. INDEXCON.	s	2,211,244			OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
ID0509	MANUFACTURE OF PLANAI WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCA REF. INDEXCON.	S	9715185.6	2 316 185		MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	MANUFACTURE OF PLANAF WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.	3	209343/97	-		MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.
ID0509	MANUFACTURE OF PLANAR WAVEGUIDE COMPONENTS WITH DISPERSIVE ELEMENTS AND FINE LOCAL REF. INDEXCON.		08/896,092	6,115,518		OPTICAL WAVEGUIDE BRAGG REFLECTION GRATINGS
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	CA	2,282,939			OPTICAL EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	DE	99306728.9	699 01 419.0		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	EP	99306728.9	1 009 078	Nat'l Phase Filed	OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	FR	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	GB	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	IT	99306728.9	1 009 078		OPTICAL GAIN EQUALIZER
ID0997	SERIAL FILTERING FOR WAVELENGTH FLATTENING OF E.D.F.A.	US	09/209,387	6,321,000		OPTICAL EQUALIZER
ID8550	OPTICAL FIBRES	GB	8230675	2 129 152		OPTICAL FIBRES

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ID9170		CA	500,513	1,288,267	BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	GB	8503506	2 170 920	BEAM SPLITTER/COMBERS
ID9170	BEAM SPLITTER/COMBERS	US	06/819,125	4,756,589	BEAM SPLITTER/COMBERS
ID9441	DIRECTIONAL COUPLER	DE	378 25 37.2	378 25 37.2	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	FR	87302418.6	0 246 737	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	GB	8612660	2 190 762	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	JP	118687/87	2022576	DIRECTIONAL COUPLER
ID9441	DIRECTIONAL COUPLER	US	07/032,783	4,801,185	DIRECTIONAL COUPLER
ID9579	GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS	GB	8716382	2 207 254	GLASS CLAD OPTICAL FIBRE DIRECTIONAL COUPLERS
ID9730	DOPED ELEMENTS	GB	8820848.3	2 222 400	DOPED ELEMENTS
ID9758	"OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING"	GB	8926061.6	2 238 396	"OPTICAL WAVEGUIDE TAPER HAVING CORE, INTERLAYER AND CLADDING"
RO2922	POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ON BIREFRINGENCE COMPENSATION	US	08/329,923	5,488,679	POLARIZATION INDEPENDENT WAVELENGTH TUNABLE FILTER BASED ONBIREFRINGENCE COMPENSATION